

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 8, 2025	
IGI Report Number	LG671433180
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	7.54 X 5.48 X 3.82 MM

GRADING RESULTS

Carat Weight	1.54 CARAT
Color Grade	FANCY VIVID YELLOW
Clarity Grade	VS 1

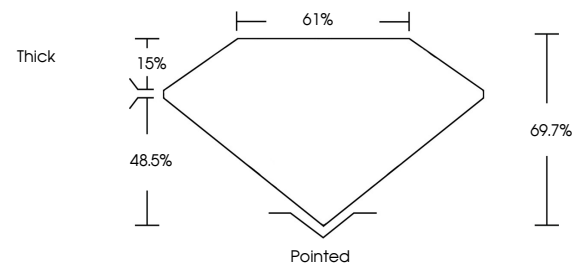
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG671433180

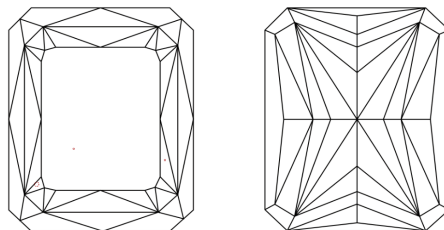
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG671433180
Report verification at [igi.org](https://www.igi.org)

PROPORTIONS

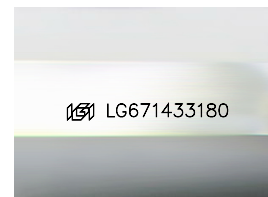


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF WVS¹⁻² VS¹⁻² SI¹⁻² |¹⁻³

Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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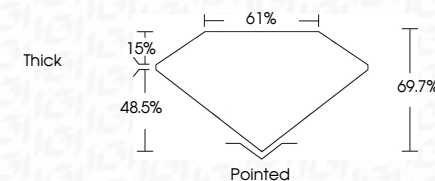
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